

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant	:	Shimizu <i>et al.</i>
Appl. No.	:	10/618,900
Filed	:	July 14, 2003
For	:	SINGLE-WAFER-PROCESSING TYPE CVD APPARATUS
Examiner	:	Rudy Zervigon
Group Art Unit	:	1792
Conf. No.	:	7366

**COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE****Mail Stop Issue Fee**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Applicants appreciate the finding of the pending claims to be allowable. In the Statement of Reasons for Allowance accompanying the Notice of Allowability mailed October 9, 2008, the Examiner noted various features of amended independent Claim 1.

Applicants assume that, pursuant to M.P.E.P. § 1302.14, the Examiner has stated some, but not all of the reasons for allowance of the claims. As a result, the statements made in the Reasons for Allowance do not necessarily relate to or completely set out the reasons for allowance of each and every claim. For example, Applicants submit that the claims depending from independent Claim 1 recite additional limitations distinguishing the art of record. To the extent that the Examiner's paraphrasing of the subject matter of the claims deviates from the actual language of the claims, the Applicants respectfully disagree with the Reasons for

Allowance. Applicants also wish to point out that the claims are patentable based on the combination of elements recited therein and not on any particular feature. Accordingly, to the extent that the Reasons for Allowance omit claim elements, Applicants respectfully disagree with the Reasons for Allowance.

Respectfully submitted,  
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: November 6, 2008

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